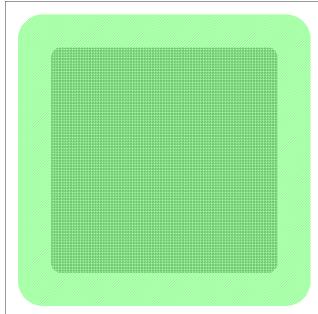


**SiC Silicon-Carbide**

**650V 10A Schottky Diode**

<b>Bonding Pad Information</b>		<b>Chip Information</b>	
	Die Size (With Scribe Line) : 1,651μm x 1,651μm Anode Pad Size : 1,101μm x 1,101μm Scribe Line Size : 100μm Wafer Size : 4inches Wafer Thickness : 160μm Gross Die : 2,402ea		Al/Cu : 4.0μm Ti/Ni/Ag : 2.0μm

**Maximum Ratings (T<sub>c</sub>=25°C unless otherwise noted)**

Parameter	Symbol	Value	Unit
Repetitive Peak Reverse Voltage	V <sub>RRM</sub>	650	V
Surge Peak Reverse Voltage	V <sub>RSM</sub>	650	V
DC Current @ T <sub>J</sub> =150°C	I <sub>F</sub>	10	A
Operating Junction and Storage Temperature Range	T <sub>J</sub>	-55 to 175	°C

**Electrical Characteristics (T<sub>A</sub>=25°C unless otherwise noted)**

Parameter	Symbol	Conditions	Min.	Typ.	Max.	Unit
DC Blocking Voltage	V <sub>R</sub>	I <sub>R</sub> =100uA, T <sub>J</sub> =25°C	650	800	-	V
		I <sub>R</sub> =100uA, T <sub>J</sub> =175°C	650	785	-	
Forward Voltage	V <sub>F</sub>	I <sub>F</sub> =10A, T <sub>J</sub> =25°C	-	1.4	1.7	V
		I <sub>F</sub> =10A, T <sub>J</sub> =150°C	-	1.8	2.2	
		I <sub>F</sub> =10A, T <sub>J</sub> =175°C	-	1.9	2.4	
Reverse Current	I <sub>R</sub>	V <sub>R</sub> =650V, T <sub>J</sub> =25°C	-	1	50	μA
		V <sub>R</sub> =650V, T <sub>J</sub> =150°C	-	9	90	
		V <sub>R</sub> =650V, T <sub>J</sub> =175°C	-	20	200	
Total Capacitive Charge	Q <sub>c</sub>	V <sub>R</sub> =400V, T <sub>J</sub> =25°C $Q_c = \int_0^{V_R} C(V) dV$	-	22	-	nC
Total Capacitance	C <sub>j</sub>	V <sub>R</sub> =0.1V, f=1MHz	-	403	-	pF
		V <sub>R</sub> =200V, f=1MHz	-	44	-	
		V <sub>R</sub> =400V, f=1MHz	-	38	-	